

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**



Re application of

Docket No: Q63680

Kohei ABUKAWA

Appln. No.: 09/821,020

Group Art Unit: 1775

Confirmation No.: 5550

Examiner: Archene Turner

Filed: March 30, 2001

For: SILICON NITRIDE MEMBER, METHOD FOR MANUFACTURING THE SAME, AND CUTTING TOOL

**NOTICE OF APPEAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated February 27, 2004.

A check for the statutory fee of \$330.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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330.00 DP

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Respectfully submitted,

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Date: August 26, 2004